

PATENT APPLICATION

Sheet 1 of 9

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| FORM PTO-1449 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT <small>(Use several sheets if necessary)</small> | ATTY. DOCKET NO. | APPLICATION NO. | CONFIRMATION NO. |
| | 200315134-1 | 10/799,325 | |
| | APPLICANT | | |
| | Randy L. Hoffman Herewith | FILING DATE | GROUP |

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

| EXAMINER INITIAL | DOCUMENT NUMBER | PUBLICATION DATE | NAME | Pages, Columns, Lines Where Relevant Passages or Figures Appear |
|------------------|-----------------|------------------|--------------------|---|
| TT | 1A 4,559,238 | 12/17/2985 | Bujatti, et al. | |
| TT | 1B 5,107,314 | 04/21/1992 | Kahng, et al. | |
| TT | 1C 5,744,864 | 08/28/1998 | Cillessen, et al. | |
| TT | 1D 2003/0047785 | 03/13/2003 | Kawasaki, et al. | 03/20 03 |
| TT | 1E 2003/0104659 | 08/05/2003 | Arakawak, et al. | |
| TT | 1F 2003/0111663 | 06/19/2003 | Yagi | |
| TT | 1G 2003/0139026 | 07/24/2003 | Lucovosky | |
| TT | 1H 2003/0180996 | 09/25/2003 | Yamazaki, et al. | |
| TT | 1I 2003/0186489 | 10/02/2003 | Ishikawa | |
| TT | 1J 2003/018221 | 11/27/2003 | Wager, III, et al. | |
| TT | 1K 2003/018222 | 11/27/2003 | Wager, III, et al. | |

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5/22/09

FOREIGN PATENT DOCUMENTS

| | | DOCUMENT NUMBER | PUBLICATION DATE | NAME OF PATENTEE OR APPLICANT | Pages/Columns/Lines Where Relevant Passages/Figures Appear | Check if Translation attached |
|----|----|-----------------|------------------|-------------------------------|--|-------------------------------|
| TT | 1L | WO 97-06544 | 02/20/1997 | Cillessen, et al. | | |
| TT | 1M | EP1134811 | 09/19/2001 | Kawasaki, et al. | | |
| | 1N | | | | | |
| | 1O | | | | | |
| | 1P | | | | | |

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

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| TT | 1Q | Aoki, Akira, et al., "Tin Oxide Thin Film Transistors", Japan J. Appl. Phys., Vol. 9, p.582 (1970). |
| TT | 1R | Garcia, P.F., et al., "Transparent ZnO thin-film transistor fabricated by rf magnetron sputtering", Applied Physics Letters, Vol. 82, No. 7, pp. 1117-1119 (February 17, 2003). |
| TT | 1S | Garcia, P.F., et al., "ZnO Thin Film Transistors for Flexible Electronics", Mat. Res. Soc. Symp. Proc., Vol. 769, pp. H72.1-H72.6 (2003). |

| EXAMINER | DATE CONSIDERED |
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| Thien Kieu | 10-11-2005 |

PATENT APPLICATION

Sheet 2 of 9

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| FORM PTO-1449 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary) | | ATTY. DOCKET NO. 200315134-1 | APPLICATION NO. 10/799, 325 | CONFIRMATION NO. |
| | | APPLICANT Randy L. Hoffman | | |
| | | FILING DATE Herewith | GROUP | |

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

| EXAMINER INITIAL | | DOCUMENT NUMBER | PUBLICATION DATE | NAME | Pages, Columns, Lines Where Relevant Passages or Figures Appear |
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| TT | 2A | 2003/0224550 | 12/04/2003 | Kokubo, et al. | |
| TT | 2B | 60/490,239 | 07/25/2003 | | Transparent Thin Film Transistor with Zinc-Tin Oxide Channel... |
| TT | 2C | 10/763,239 | 01/23/2004 | | Semiconductor Device |
| TT | 2D | 10/763,354 | 01/23/2004 | | Transistor Including a Deposited Channel Region Having a ... |
| | 2E | | | | |
| | 2F | | | | |
| | 2G | | | | |
| | 2H | | | | |
| | 2I | | | | |
| | 2J | | | | |
| | 2K | | | | |

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5/26/07

FOREIGN PATENT DOCUMENTS

| | | DOCUMENT NUMBER | PUBLICATION DATE | NAME OF PATENTEE OR APPLICANT | Pages/Columns/Lines Where Relevant Passages/Figures Appear | Check if Translation attached |
|--|----|-----------------|------------------|-------------------------------|--|-------------------------------|
| | 2L | | | | | |
| | 2M | | | | | |
| | 2N | | | | | |
| | 2O | | | | | |
| | 2P | | | | | |

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

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| TT | 2Q | Fu, Shelton, et al., "MOS and MOSFET with Transition Metal Oxides", SPIE Vol. 2697, pp. 520-527. |
| TT | 2R | Giesbers, J.B., et al., "Dry Etching of All-Oxide Transparent Thin Film Memory Transistors", Microelectronic Engineering, Vol. 35, pp. 71-74 (1997). |
| TT | 2S | Grosse-Holz, K.O., et al. "Semiconductive Behavior of Sb Doped SnO ₂ Thin Films", Mat. Res. Soc. Symp. Proc., Vol. 401, pp. 67-72 (1996). |

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| | Ihnen, Hale | 10-11 - 2005 |